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Substitute for form 1449/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet	1	of	1
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Complete if Known

Application Number	10761500
Filing Date	01-20-2004
First Named Inventor	Sang Woo NAM
Art Unit	
Examiner Name	
Attorney Docket Number	OG03-034 / DAS-010

U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

**Examiner
Signature**

/Nicole Blan/

Date
Considered

05/16/2007

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PTC/SB/00A (07-05)

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Application Number	10/781,500
Filing Date	January 20, 2004
First Named Inventor	Sang Woo NAM et al.
Art Unit	1745
Examiner Name	
Attorney Docket Number	SPO200512-0108US (OG03-034)

U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

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PTO/SB/088 (07-05)

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Substitute for form 1449/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Complete if Known

Application Number	10/761,500
Filing Date	January 20, 2004
First Named Inventor	Sang Woo NAM et al.
Art Unit	1745
Examiner Name	
Attorney Docket Number	SPO200512-0108US (OG03-034)

Sheet 2 of 2

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	73
/NB/	CA	GI Jun OH; Cleaning Solution and Method for Cleaning Metal Layer Using the Same; Korean Patent Abstract; Publication No. 1020030048121A; Publication Date: June 25, 2003; Korean Intellectual Property Office	
/NB/	CB	Office Action dated March 10, 2006 from Chinese Patent Office for Chinese Patent Application No. 2004100080823, titled: "Method and Apparatus for Manufacturing Semiconductor Devices"; 8 Pages	
/NB/	CC	English translation of Office Action dated March 10, 2006 from the Chinese Patent Office for Chinese Patent Application No. 2004100080823, titled: "Method and Apparatus for Manufacturing Semiconductor Devices"; 11 Pages	

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Application Number	10/761,500
Filing Date	January 20, 2004
First Named Inventor	Sang Woo NAM et al.
Art Unit	1745
Examiner Name	
Attorney Docket Number	A2003-S0851US/SPO200512-0108US

Sheet	1	of	2
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code ² Number ³ Kind Code ⁴ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	1 ⁵
/NB/	DB	JP 10-116809	05-08-1998	Omi Tadahiro, et al.		
/NB/	DC	JP 08-182425	06-21-1996	Mitsubishi Electric Corp		
/NB/	DD	JP 05-152268	06-18-1993	Mitsubishi Electric Corp		

05/16/2007

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FEB 20 2007

PTO/SB/089 (07-06)

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Substitution for form 1449/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Complete If Known			
		Application Number	10781,500		
		Filing Date	January 20, 2004		
		First Named Inventor	Sang Woo NAM et al.		
		Art Unit	1745		
		Examiner Name			
Sheet	2	of	2	Attorney Docket Number	A2003-S0651US/SPO200512-0108US

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Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
/NB/	EA	Tadahiro OMI et al.; Method and System for Washing; Japanese Patent Abstract; Publication No. 10-116809; Publication Date: May 6, 1998; Japan Patent Office	
/NB/	EB	Shigeru HARADA et al.; Manufacture and Manufacturing Method of Semiconductor Integrated Circuit Device; Japanese Patent Abstract; Publication No. 08-162425; Publication Date: June 21, 1998; Japan Patent Office	
/NB/	EC	Itaru SUGANO; Removal of Resist Residue; Japanese Patent Abstract; Publication No. 05-152268; Publication Date: June 18, 1993; Japan Patent Office	
	ED	Office Action, Japanese Patent Application No. 2004-084262, believed to be dated on or around January 18, 2007	

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